

SEP 16 1981



LITTON INDUSTRIES

4825 Scott Street, Schiller Park, Illinois 60176  
Telephone: 312 671-2930  
Telex: 651490 (Attn: LSPW)  
TWX: 910-4941231 (Attn: LSPW)

Law Department

September 14, 1981

Missouri Department of Natural Resources  
P. O. Box 1368  
1915 Southridge Drive  
Jefferson City, Missouri 65102  
ATTN: Mr. Ed Lightfoot

RECEIVED

SEP 17 1981

SOLID WASTE  
MANAGEMENT PROGRAM

RE: Advanced Circuitry Division, Litton Systems, Inc.  
4811 West Kearney  
Springfield, Missouri

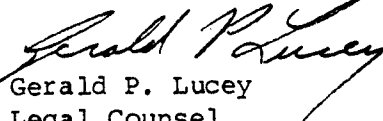
Dear Mr. Lightfoot:

This letter is intended to confirm our telephone conversation of September 9, 1981, wherein I advised you that I represent the Advanced Circuitry Division, Litton Systems, Inc. In your letter dated July 31, 1981, you established October 9, 1981 as the date for compliance with the financial responsibility requirements for closure. As I explained, Litton's Insurance Department in conjunction with Marsh & McLennon have been unable to locate a surety company that is willing to write a bond to satisfy these financial responsibility requirements. If you are able to provide me with the name of any surety companies writing these bonds, this information will be most helpful.

Assuming we are unable to locate a surety company, it would be appreciated if your office would consider granting Advanced Circuitry a waiver or variance from the financial responsibility requirements. Advanced Circuitry will discontinue the use of its sanitary and wastewater lagoons as soon as it can commence using the Municipal Sewer System. The extension of the Municipal Sewer System should be completed within the next few months and the System should be operative in January, 1982. Since the closure of these lagoons will commence in the foreseeable future, I hope it will be possible for the Department of Natural Resources to grant Advanced Circuitry either a waiver or a variance.

Very truly yours,

LITTON SYSTEMS, INC.

  
Gerald P. Lucey  
Legal Counsel



R00337269

RCRA RECORDS CENTER

GPL/cs

cc: M. Doram  
R. Enos  
D. Miller  
P. Meiburger